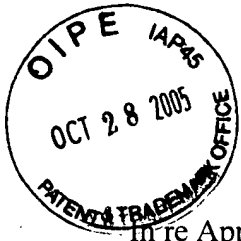


AF/DW

Docket No.: 061282-0035

**PATENT**



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**RESPONSE UNDER 37 C.F.R. 1.116**  
**EXPEDITED PROCEDURE**

In re Application of

ITO, MITSUMI, et al.

Application No.: 10/634,988

Filed: August 06, 2003

: Customer Number: 20277  
:  
: Confirmation Number: 7469  
:  
: Group Art Unit: 2825  
:  
: Examiner: Stacy Whitmore  
:

For: SEMICONDUCTOR DEVICE, METHOD OF GENERATING PATTERN FOR  
SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR  
DEVICE AND DEVICE OF GENERATING PATTERN USED FOR SEMICONDUCTOR  
DEVICE

**REQUEST FOR RECONSIDERATION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 28, 2005, having a three-month shortened statutory period for response set to expire on October 28, 2005, reconsideration of the above-identified application is respectfully requested in view of the following remarks.